

**AMENDMENTS TO THE SPECIFICATION**

Please amend the title as indicated below:

~~CAPACITOR AND METHOD FOR FORMING A CAPACITOR~~

Please insert the heading and paragraph below on page one below the heading "Background".

**CROSS-REFERENCE TO RELATED APPLICATION**

This is a division of U.S. Patent Application Serial No. 10/236,311 filed September 6, 2002 (now U.S. Patent No. \_\_\_\_\_).

Please amend the eighth paragraph on page five as indicated below:

Referring to Fig. 7, a process, such as a blanket etch-back process using a reactive ion etching method, is carried out to remove a portion of the ~~pt~~ Pt layer 8 and leave the Pt layer 8 remaining on the upper surface of the metal layer 7.